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			Application Number	National Stage of PCT/JP03/16816 10/540995	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(use as many sheets as necessary)</i>			Confirmation Number	Unknown	
			Filing Date	June 28, 2005	
			First Named Inventor	Takashi UDAGAWA	
			Art Unit	Unknown	
			Examiner Name		
			Attorney Docket Number	Q73765	
Sheet	1	of	1		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>2</sup> (if known)		
JS		US 2003/0001162	A1	01/02/2003	TAKASHI UDAGAWA
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JS		US 6,069,021	A	05/30/2000	KAZUTAKA TERASHIMA, ET AL
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>4</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			
JS		EP	0 395 392	A	10/31/1990	TOKYO SHIBAURA ELECTRIC CO.	
JS		JP	2-288388	A	11/28/1990	TOSHIBA CORP	Abstract
JS		JP	10-242567	A	09/11/1998	TOSHIBA CORP	Abstract

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation <sup>4</sup>
JS		PATENT ABSTRACTS OF JAPAN Vol. 1998, No. 01, January 30, 1998 & JP 09-232685 A (TOSHIBA CORP), September 5, 1997	
		Journal of the Japanese Association for Crystal Growth, Vol. 24, No. 2, P150, (1974)	Abstract
		K. SHOHNO, ET AL, "EPITAXIAL GROWTH OF BP COMPOUNDS ON Si SUBSTRATES USING THE B <sub>2</sub> H <sub>6</sub> -PH <sub>3</sub> -H <sub>2</sub> SYSTEM" JOURNAL OF CRYSTAL GROWTH, Vol. 24/25, 1974, pages 193-196	
		Y. KUMASIRO, ET AL, "PREPARATION AND ELECTRICAL PROPERTIES OF BORON AND BORON PHOSPHIDE FILMS OBTAINED BY GAS SOURCE MOLECULAR BEAM DEPOSITION", JOURNAL OF SOLID STATE CHEMISTRY, Vol. 133, 1997, pages 269-272	
JS		T. IZUMIYA, ET AL, "GROWTH OF BP AND GaN/BP HETEROSTRUCTURES", INST. PHYS. CONF. SER., No. 129 CHAPTER 3, (IOP PUBLISHING LTD., UK), pages 157-162 (1992)	

Examiner Signature	<i>Harold Schulz</i>	Date Considered	11/22/07
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to indicate here if English language Translation is attached.